

Notice of References Cited

Application/Control No.

09/779,877

Applicant(s)/Patent Under
Reexamination
HASEGAWA ET AL.

Examiner

Hai H. Huynh

Art Unit

3747

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*		Document Number	Date	Name	Classification	
		Country Code-Number-Kind Code	MM-YYYY			
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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